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10/802,806	03/18/2004 RULE	438	2813	021740A
APPLICANTS Katsutoshi Izumi, Osaka, JAPAN; Motoi Nakao, Osaka, JAPAN; Yoshiaki Ohbayashi, Nara-shi, JAPAN; Keiji Mine, Osaka, JAPAN; Seisaku Hirai, Osaka, JAPAN; Fumihiko Jobe, Osaka, JAPAN; Tomoyuki Tanaka, Osaka, JAPAN;				
** CONTINUING DATA ***** This application is a DIV of 10/351,385 01/27/2003 <i>HD</i>				
** FOREIGN APPLICATIONS ***** JAPAN 2002-022631 01/31/2002 <i>HD</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/03/2004				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <i>Shaker Dohy</i> <i>HD</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 2 INDEPENDENT CLAIMS 2
ADDRESS 23850				
TITLE Manufacturing apparatus for buried insulating layer-type semiconductor silicon carbide substrate				
FILING FEE RECEIVED 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	